





Appleant: Y. Ahn et al.

Title: ATOMIC LAYER-DEPOSITED LaAIO3 FILMS FOR GATE DIELECTRICS

Docket No.:

1303.050US2

February 27, 2004

Examiner:

Filed:

Allan R. Wilson

Serial No.: 10/789,042

Due Date: July 12, 2006 Group Art Unit: 2815

MS Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

 \underline{X} Return postcard.

X Response to Notice of Non-Compliant Amendment (10 pgs.).

If not provided for in a separate paper filed herewith, please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

Atty: David R. Cochran Reg. No. 46,632

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this ______ day of July, 2006.

Name

Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

KIE Y. AHN ET AL.

Examiner: Allan R. Wilson

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RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

This responds to the Notice of Non-Compliant Amendment mailed on June 12, 2006. In compliance with 37 CFR 1.121, Applicant submits the following corrected section from Applicants' previously-submitted Amendment and Response filed May 23, 2006.